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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570

Group Art Unit: 2812

Filed: August 14, 2000

Examiner: Ha T. Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION
METHOD, METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that a one-month Extension of Time, to and including August 24, 2002, be granted in which to respond to the Office Action dated April 24, 2002 in the above-identified application.

Our check including the amount of \$110.00 is attached in payment of the appropriate fee.

The Commissioner is hereby authorized to charge any additional payment due, or to credit any overpayment, to Deposit Account No. 50-1417.

Respectfully submitted,


John R. Mattingly

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Date: August 26, 2002